

<b>Notice of References Cited</b>	Application/Control No. 10/605,078	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0135738	07-2004	Kim et al.	345/001.1
*	B	US-2003/0025677	02-2003	Iwamoto et al.	345/173
	C	US-			
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	F	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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